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Rib Data Sheet

CONFIRMATION NO. 8651

SERIAL NUMBER 10/060,569	FILING DATE 01/29/2002 RULE	CLASS 438	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. N230500C1
APPLICANTS Migaku Kobayashi, Tokyo, JAPAN;				
** CONTINUING DATA ***** THIS APPLICATION IS A CON OF 09/640,959 08/16/2000 <i>now abandoned</i> <i>gag 4-021</i>				
** FOREIGN APPLICATIONS ***** JAPAN 230500/1999 08/17/1999 <i>gag 4-021</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/28/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>gag 4-021</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 20
Verified and Acknowledged Examiner's Signature _____ Initials _____		INDEPENDENT CLAIMS 3		
ADDRESS Darryl G. Walker WALKER & SAKO, LLP Suite 235 300 South First Street San Jose, CA 95113				
TITLE Method of fabricating a semiconductor device				
FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	